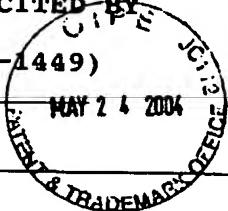


Sheet 1 of 1								Atty. Docket No. 4616/CON of 4194		Serial No.: 10/725,860					
LIST OF REFERENCES CITED BY APPLICANT (REVISED FORM PTO-1449) DATED: February 25, 2004								Applicant: Hirokazu KUGAI et al.							
MAR 01 2004								U.S. Filing Date: December 1, 2003		Art Unit:					
U.S. PATENT DOCUMENTS															
*EXAMINER INITIAL		DOCUMENT NO.							DATE	NAME		Cl.	Sub-Cl.	Fil. Date	
EP	AA	5	1	4	1	6	1	4	08/1992	Akr ridge et al.	-	-	-		
	AB	5	3	3	8	6	2	5	08/1994	Bates et al.	-	-	-		
	AC	6	5	6	1	0	0	4	10/1996	Bates et al.	-	-	-		
	AD	5	9	6	1	6	7	2	10/1999	Skotheim et al.	-	-	-		
EP	AE	6	1	6	8	8	0	4	01/2001	Neudecker et al.	-	-	-		
FOREIGN PATENT DOCUMENTS															
		DOCUMENT NO.							DATE	COUNTRY	Cl.	Sub-Cl.	Trans.		
													Yes	No	
EP	AF	56	1	5	6	6	7	4	12/1981	Japan	-	-	Abst.		
	AG	60	0	7	2	1	7	0	06/1996	Japan	-	-	Abst.		
	AH	08	1	6	7	4	2	5	06/1996	Japan	-	-	Abst.		
	AI	0	2	0	6	3	3	9	12/1981	Europe	-	-	x		
X	AJ	62	0	4	4	9	6	0	02/1987	Japan	-	-	Abst.		
	AK	05	0	4	8	5	8	2	07/1993	Japan	-	-	Abst. +=AI		
	AL	10	0	5	8	0	0	7	03/1998	Japan	-	-	Abst.		
	AM	10	0	8	3	8	3	8	03/1998	Japan	-	-	Abst.		
	AN	W000	/	2	8	6	0	8	05/2000	PCT	-	-	Abst.		
	AO	2001	2	8	4	0	6	8	10/2001	Japan	-	-	Abst.		
EP	AP	2002	0	1	5	7	2	8	01/2002	Japan	-	-	Abst. + =AS		
OTHER DOCUMENTS															
EP	AQ	Description of MRC sputtering system given at <a href="http://www.sctsystems.com/mrc/903/system.html">http://www.sctsystems.com/mrc/903/system.html</a>													
EP	AR	US Patent Application Publication No. US 2002/0028383 A1, published on March 7, 2002, Kugai et al., Title: Thin Alkali Metal Film Member and Method of Producing the Same; Cover page, 1 sheet of drawings, and pages 1 to 6													
EP	AS	US Patent Application Publication No. US 2003/0180608A1, published on September 25, 2003, Mori et al., Title: Lithium Secondary Cell and Method for Manufacture Thereof; cover page, 2 sheets of drawings, and pages 1 to 3.													
EXAMINER				DATE				9/23/04							
*EXAMINER: Initial if reference considered, whether or not citation is in conformance with MPEP 609; Draw line through citation if not in conformance and not considered. Include copy of this form with next communication to applicant.															

<b>Sheet 1 of 1</b> <b>SECOND</b> <b>LIST OF REFERENCES CITED BY</b> <b>APPLICANT</b> <b>(REVISED FORM PTO-1449)</b> <b>DATED: May 20, 2004</b>									Atty. Docket No. 4616/CON of 4194		Serial No.: 10/725,860			
									Applicant: Hirokazu KUGAI et al.					
MAY 24 2004 U. S. PATENT DOCUMENTS									U.S. Filing Date: December 1, 2003		Art Unit: 1745			
*EXAMINER INITIAL		DOCUMENT NO.							DATE	NAME		Cl.	Sub-Cl.	Fil. Date
EF	AT	5	5	2	2	9	5	5	06/1996	Brodd		-	-	-
EF	AU	6	3	6	5	3	0	0	04/2002	Ota et al.		-	-	-
FOREIGN PATENT DOCUMENTS														
		DOCUMENT NO.							DATE	COUNTRY		Cl.	Sub-Cl.	Trans.
EF	AV	W000	/	3	3	4	0	9	06/2000	PCT		-	-	Yes      No
OTHER DOCUMENTS														
EXAMINER									DATE	9/23/04				
*EXAMINER: Initial if reference considered, whether or not citation is in conformance with MPEP 609; Draw line through citation if not in conformance and not considered. Include copy of this form with next communication to applicant.														